



774
AFS

Docket No.: 059516-0052

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
	:	
Zi-kui LIU, et al.	:	Confirmation Number: 1022
	:	
Application No.: 10/784,899	:	Group Art Unit: 1762
	:	
Filed: February 24, 2004	:	Examiner: Brian K. Talbot
	:	
For: BORIDE THIN FILMS ON SILICON	:	

PETITION FOR EXTENSION OF TIME

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the time for response to the Office Action dated September 2, 2005, now due to expire December 2, 2005, be extended for one month(s) and set to expire on January 2, 2006.

Please charge the extension fee of \$60.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

01/03/2006 SZENDIE1 00000027 500417 10784899
01 FC:2251 60.00 DA

McDERMOTT WILL & EMERY LLP

Brian K. Seidleck
Registration No. 51,321

600 13th Street, N.W.
Washington, DC 20005-3096
Phone: 202.756.8000 BKS:ldw
Facsimile: 202.756.8087
Date: December 30, 2005

**Please recognize our Customer No. 20277
as our correspondence address.**